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Reference to:  
Application No.: 10/723,046  
Filing date: 11/26/2003  
Art unit: 2811  
Applicant: Hui Peng  
Title: Texture of Substrate and a Method for Minimizing Effects of Latent Mismatch  
Examiner/Art Unit: Shunxing Huo/2811

Fremont, CA, June 27, 2005

AMENDMENT A

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

This letter responds to the Office Action Summary dated May 24, 2005 and mailed to applicant on 5/31/2005. Please amend the above patent application as the following.

THE replace with following new title:

"Texture for Localizing and Minimizing Effects of Latent Constants Mismatch"

SPECIFICATION: There is no amendment to the specification.

CLAIMS: Amendment to the claims of the above patent application begin on page 2 of this amendment.

DRAWINGS: There is no amendment to the drawings.

REMARKS: Remarks begin on page 5 of this amendment.